

FORM PTO-1449	US Dept. of Commerce Patent and Trademark Office	ATTORNEY DOCKET NO. ATMI-520	SERIAL NO. 09/935,805
INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)		APPLICANT Ying Ma, et al.	
		FILING DATE August 23, 2001	GROUP 172 1763

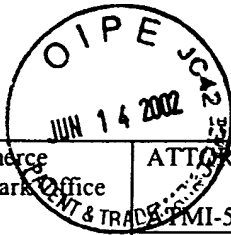
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS FILING DATE OF APPROPRIATE
gag	AA	6,409,781	6-25-02	Thomas H. Baum, et al.		5/1/2000
	AB	6,117,775	9/12/2000	Kondo, et al.		
	AC	6,221,774	4/24/2001	Malik		
	AD	5,972,792	10/26/1999	Hudson		
	AE	6,232,231	5/15/2001	Sethuraman, et al.		
gag	AF	5,985,748	11/16/99	Watts, et al.		
	AG					

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO	
							(abstract only)	
gag ✓	AH	01/23486	4/5/2001	World ✓				

OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)	
gag	AK * Shyama P. Mukherjee, et al., Mat. Research Soc. Symp. Vol. 613, "Planarization of Copper Damascene Interconnects by Spin-Etch Process; A Chemical Approach (2000).
gag	AJ Yongsik Moon, et al., Finishing of Advanced Ceramics and Glasses Symposium at the 101 st Annual Meeting of the American Ceramic Society, pgs. 269-279, "IDENTIFICATION OF THE MECHANICAL ASPECTS OF MATERIAL REMOVAL MECHANISMS IN CHEMICAL MECHANICAL POLISHING (CMP). (April 25-28, 1999).
gag	AK Seiichi Kondo, et al., Journal of the Electrochemical Society, 147 (10) pgs. 3907-3913, "Abrasive-Free Polishing for Copper Damascene Interconnection" (2000).

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EXAMINER <i>George Gouldrean</i>	DATE CONSIDERED 3-031
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* Reference is unavailable for review by the examiner.



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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>gag</i>	AA	US 5, 866,031	2/2/1999	Carpio, et al.			5/12/2000
<i>gag</i>	AB	US 5,858,813	1/12/1999	Scherber, et al.			
<i>gag</i>	AC	US 5,922,091	7/13/1999	Tsai, et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO
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OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)							
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EXAMINER <i>George Goudreau</i>					DATE CONSIDERED <i>3-031</i>		
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